

#12 / Amended
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TECHNOLOGY CENTER 2800

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2811**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tomoyoshi KUSHIDA

Application No.: 09/435,766

Filed: November 8, 1999

For: SEMICONDUCTOR DEVICE

Group Art Unit: 2811

Examiner: S. Loke

Docket No.: 104361

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In reply to the Office Action mailed January 18, 2002, please amend the above-identified application as follows:

IN THE CLAIMS:

Please replace claims 1, 4, 12, 22-23, 26 and 28-30 as follows:

- 01
sub E1
1. (Three Times Amended) A bipolar semiconductor device comprising:
a drain electrode;
a drain region having a first conductive type and disposed on the drain electrode;
a drift region having a second conductive type different from the first conductive type of the drain region and disposed on the drain region;